

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants: S. TAI, et al.
 Serial No.: 10/784,996
 Filed: FEBRUARY 25, 2004
 Title: PROCESS FOR PREPARING PHOSPHOR PATTERN FOR FIELD EMISSION DISPLAY PANEL, PHOTOSENSITIVE ELEMENT FOR FIELD EMISSION DISPLAY PANEL, PHOSPHOR PATTERN FOR FIELD EMISSION DISPLAY PANEL AND FIELD EMISSION DISPLAY PANEL
 Group AU: 1756
 Examiner: John A. McPherson
 Confirm. No.: 9776

RESPONSE

Mail Stop: AMEND – FEE
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, Virginia 22313-1450

December 5, 2005

SIR:

In response to the Office Action mailed June 28, 2005, the period for response having been extended for three (3) months by the attached Petition for Extension of Time, Applicants respectfully submit the enclosed Terminal Disclaimer and enclosed Translation of Japanese Patent Application No. 132254/1997 (Priority Application), with Declaration of accuracy of the translation, and, additionally, the following Remarks, for obviating claim rejections in this Office Action mailed June 28, 2005.

Initially, the obviousness-type double patenting rejection, over claims 1 and 2 of U.S Patent No. 6,416,931, set forth in Item 1 on pages 2 and 3 of the Office Action mailed June 28, 2005, is noted. The Examiner has indicated that this obviousness-type double patenting rejection can be overcome with a timely filed Terminal Disclaimer. In light thereof, enclosed please find a Terminal Disclaimer for the